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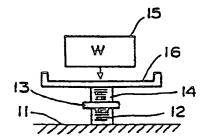
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(54) Weight sensor device.

electric elements (12, 14). The first piezoelectric element (14) induces vibration in an object to be measured, and the second one (12) detects the reaction force of the object generated by the vibration. This force is detected by a voltage monitor circuit as an output voltage from the second piezoelectric element (12). From the voltage which has been detected, the weight of object is determined. The device further includes an absorbing element (13) to absorb unnecessary piezoelectric strain in reaction force generated when the object vibrates. The invention provides a compact weight sensor which can be produced at low cost, and which can measure weight with high accuracy.



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This invention relates to a weight sensor device which measures the weight of an object. More specifically, the invention relates to a compact weight sensor which uses piezoelectric elements.

Background of the Invention

The weight sensor shown in Figure 10, which makes use of the deflection or a spring, is an example of a sensor device to measure the weight of an object. This weight sensor device includes, (i) table 1, which supports the object to be weighed (not illustrated), (ii) springs 2, one end of each of which is fixed to the main body of the device and the other end of which is attached to the bottom of table 1, and (iii) detector 3, which measures how much springs 2 have been displaced by the load placed on table 1. A common choice for detector 3 is an overcurrent detector including coil 4, which is fixed to the bottom of table 1, and electromagnet 6, which surrounds coil 4 and is fixed to base 5.

The type of weight sensor described above operates on the principle that the displacement of springs 2 is proportional to the load or the object to be measured. The displacement of springs 2 can be measured by detecting the change in the relative positions of coil 4 and electromagnet 6 by means of changes in the current which are induced in coil 4.

However a weight sensor device of the type described above utilizes a large number of components. Thus the device itself must be relatively large, and production is costly. Weight sensor devices to be used in home appliances, such as electronic ranges, must be particularly compact and economical. The type of sensor device described above, then, is non-optimal for this application.

In view of the circumstances described above, the objective of the present invention seeks to provide a weight sensor which is compact and economical.

Summary of the Invention

The weight sensor of this invention has a piezoelectric element resting on a base; another piezoelectric element fixed to the first element in a coaxial fashion; a drive device which vibrates one of the two aforesaid piezoelectric elements and so induces periodic vibration in an object whose weight is to be measured; and a device which detects, by means of the output voltage from the other piezoelectric element, the reaction force generated in the aforesaid object when vibration is induced. In a weight sensor with the structure described above, periodic vibration is induced in an object whose weight is to be measured when one of the piezoelectric elements is driven by a drive device. The reaction force of the object is converted to voltage by the other piezoelectric element, and this output voltage is detected by a device for that purpose. By means of this output voltage, the weight of the object can be measured. Thus the structure of the weight sensor is simplified, and a compact and economical sensor results.

Another aspect of the invention is to absorb the piezoelectric strain generated at a horizontal direction to the plane of vibration of the piezoelectric element driven by the drive device, so that the other piezoelectric element can detect only vertical reaction force.

This absorbing means can be realized by inserting a plate or small contact article between the two piezoelectric elements.

Thus this strain is not transmitted to the second piezoelectric sensor, which outputs a voltage proportional to the strain of the reaction force only. In this way the weight of the object can be measured with high accuracy.

Brief Description of the Drawings

The above summarized invention is described with reference to the attached figures in which:

Figure 1 shows a structure of a weight sensor device in which this invention has been implemented:

Figure 2 is a functional block diagram of the weight sensor device in Figure 1;

Figure 3(a) shows an AC voltage applied to one of the piezoelectric elements;

Figure 3(b) shows displacement of a table resulting from application of an AC voltage to the piezoelectric element shown in Fig. 3(a);

Figure 3(c) shows the reaction force;

Figure 4 shows another type of weight sensor device in which this invention has been implemented;

Figure 5 is a frontal view of the weight sensor device shown in Figure 4;

Figure 6 shows a structure of another embodiment of the weight sensor device of this invention:

Figure 7 shows directions in which strain is generated when a first piezoelectric element induces vibration in the object;

Figure 8 shows the relationship between the weight of the object to be measured and the detected voltage;

Figure 9 shows a structure of another embodiment of the weight sensor of this invention; and

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Figure 10 shows a structure of one example of an existing weight sensor device.

Detailed Description of the Preferred Embodiments

Figures 1 and 2 show the structure of an embodiment of this invention. In the weight sensor device, shown generally at 100 in Figure 1, piezoelectric element 12 rests on base 11, and piezoelectric element 13 in fixed to element 12 in a coaxial fashion. On top of piezoelectric element 13 is mounted table 15, on which the object whose weight is to be measured is placed. As shown in Figure 2, oscillator circuit 16, which is the drive device, is connected to piezoelectric element 13. By applying a voltage to the oscillator circuit 16, the drive circuit causes piezoelectric element 13 and table 15 to vibrate at a given frequency vertically. Voltage monitor circuit 17, which detects the reaction force generated in object 14 by the vibration induced by piezoelectric element 13, is connected to piezoelectric element 12.

When the piezoelectric element receives force from the exterior at a vertical direction with respect to its electrodes, it undergoes internal polarization. As a result, voltage is generated which can be applied to an acceleration sensor or the like. However, when a piezoelectric element is used to detect a static force such as weight, there will be internal loss in the element, and it will not be possible to achieve stable output voltage.

However, the output voltage characteristics depend on the frequency of the force applied to the piezoelectric element. Thus, if a small piezoelectric element is to be used to detect weight, it will be necessary to apply excitation to the element in the form of an AC current.

An AC voltage v is applied to piezoelectric element 13, as shown in Figure 3 (a). Vibration of frequency ω is induced in table 15. As a result, piezoelectric element 13 causes table 15 to undergo displacement x, as shown in Figure 3 (b). The displacement X can be expressed by the following formula.

$$X = (x/2) \sin \omega t + x/2$$
 (1)

Where x in the amplitude of displacement from the vibration of table 15.

In this situation, the acceleration α experienced by table 15 when it has on it an object 15 of weight w can be expressed by the following formula after differentiating twice.

$$\alpha = -(x/2) \omega^2 \sin \omega t \qquad (2)$$

The waveform of the reaction force F which is applied to base 11 and also to piezoelectric ele-

ment 12 by above acceleration α is shown in Figure 3 (c). Its magnitude can be expressed by the following formula.

$$F = (w/g) \cdot \alpha = (w/g) ((-x/2)\omega^2) \cdot \sin \omega t$$
 (3)

If the frequency ω and the amplitude x are held constant, the reaction force F can be expressed as a temporal function of the weight w. Thus, the reaction force F applied to piezoelectric element 12 will vary proportionally with the weight W; and the voltage value V_a output by piezoelectric element 12 will also vary. By monitoring this voltage, we can measure the weight W. That is to say, V_a is directly proportional to W.

The principle given above can be used in a weight sensor device structured as shown in Figures 1 and 2. By measuring the voltage output by voltage monitor circuit 17, the weight W of object 14 can be obtained.

The weight sensor of this invention is constructed of two piezoelectric elements, 12 and 13. It has a simple configuration, it is compact and light, and it costs less than its predecessors.

As can be seen in Equation (3), if the amplitude x is set at a higher value, the detection response will improve. This being the case, it would be desirable to use a multi-layer-type element for piezoelectric element 13, as this sort of element is capable of a large displacement at a low voltage.

As shown in Figures 4 and 5, a weight sensor device 102 with the structure described above can have three weight sensors 21A, 21B and 21C, which are mounted in three locations on a base 22. In this case, the load applied to each of sensors 21A, 21B and 21C will vary according to the position of the load W of object 14. We are thus able to obtain both the position of object 14 and its weight distribution. It is possible use the individual voltages or a total value of the voltages to determine weight and from the individual voltages to determine weight distribution.

The above embodiment suggests one possible configuration for the weight sensor. Other configurations which apply the principles of this invention may also be used. For example, piezoelectric element 13, which serves to induce vibration, may be placed below piezoelectric element 12. The voltage may be monitored by piezoelectric element 12 at a fixed frequency, or the peak value may be read.

With reference to Figures 6-9, we shall explain other embodiments of the weight sensor device in which this invention has been implemented.

In Figure 6, the first piezoelectric element 12 is supported by base 11. On top of piezoelectric element 12 is plate 13, a device to absorb strain. In one example, this plate could be formed from an

aluminum plate with a thickness of approximately 5 mm. On top of plate 13 piezoelectric element 14 is fixed so that it is concentric with element 12. Table 16, on which the object to be weighed is placed, is mounted to the top of piezoelectric element 14. Piezoelectric element 14 is made to vibrate in a sinusoidal waveform by a drive device which is actually an oscillator circuit (not pictured), as previously described. Piezoelectric element 12 has a voltage monitor circuit (also not pictured) to detect output voltage, as also previously discussed. This output voltage is proportional to the reaction force of object 15, in which vibration has been induced by piezoelectric element 14.

In the weight sensor shown in Figure 6, assume that plate 13 is thin, and a single pair of piezoelectric elements, 12 and 14, are actually in direct contact with each other. As illustrated in Figure 7, when piezoelectric element 14 is made to vibrate in direction d1, contraction strain will be generated in that same element in direction d2. This contraction strain, will be communicated to piezoelectric element 12 through its contacting surface, and element 12 will detect this strain, even if there is no object 15 on table 16. Thus, under conditions of no load, the voltage V1 shown by the dotted line in Figure 8 will be generated as output from piezoelectric element 12, which serves as a detector. Voltage V1 decreases as the load increases and reaction force is applied in the direction which negates the contraction strain. From a voltage of 0V, the output again increases. Thus the output characteristics are non-linear, and it is difficult to accurately detect the reaction force.

It would be possible to set zero weight, as shown by the solid line in Figure 8, by adding some certain weight to table 16. However, this is undesirable because the weight sensor device should be compact and light enough to install in small systems.

In a device utilizing this invention, therefore, the contraction strain generated in piezoelectric element 14 in direction d2 is absorbed by the plate 13 which is sufficiently thick so as not to communicate with piezoelectric element 12. It has been experimentally determined that the contraction strain in direction d2 can be adequately absorbed by fixing plate 13, which is, for example, an aluminum plate approximately 5mm in thickness, between piezoelectric elements 12 and 14. Then when vibration has been induced in object 15, the only strain in direction d1 generated in piezoelectric element 12 will be that due to the reaction force of the object, and a voltage proportional to this strain will be output. By detecting this output voltage, one can measure the weight W of object 15 with high accuracy. As shown by the solid line in Figure 8, the relationship between detected voltag V and weight W remains linear.

The weight sensor incorporating this embodiment of the invention is constructed of two piezo-electric elements, 12 and 14. It has a simple configuration, it is compact and light, and it coats less than its predecessors. Became it has a plate 13, between piezoelectric elements 12 and 14 to absorb the contraction strain, the weight of object 15 can be measured with high accuracy.

In another embodiment, instead of plate 13 the spherical component 21 shown in Figure 9 can be used to absorb the strain. In this case, piezoelectric elements 12 and 14 make contact through spherical component 21 at only one point, so the surface area which comes in contact with piezoelectric element 12 is extremely small. Such a spherical component can be a small ball or other component, such that the intersection of the component and the piezoelectric elements is over a small area, typically a single point, such as a pinpoint. This allows the transmission of the contraction strain to be reduced virtually to zero.

The above embodiment suggests one possible configuration for the weight sensor. Other configurations which apply the principles of this invention may also be used. For example, piezoelectric element 14, which serves to induce vibration, may be placed below piezoelectric element 12, which serves as the detector.

As was explained above, the weight sensor of this invention comprises two piezoelectric elements, one of which induces vibration in the object whose weight is to be measured. The reaction force of this object is obtained as output voltage the other piezoelectric element. Thus, this sensor has a simple structure, it is compact and light, and its cost is low. Because it has a device to absorb strain between the two piezoelectric elements, the contraction strain which occurs when vibration is induced is absorbed. Thus the weight of the object can be measured with high accuracy.

While specific embodiments of the invention have been described and illustrated, it will be clear that variations in the details of the embodiments specifically illustrated and described may be made without departing from the true spirit and scope of the invention as defined in the appended claims.

Claims

- 1. A weight sensor device, comprising:
 - a table for receiving an object whose weight is to be measured;
 - a first piezoelectric element connected with said table, said first piezoelectric element inducing periodic vibration in said object;
 - a second piezoelectric element fixed to said first piezoelectric element in a coaxial

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fashion, said second piezoelectric element converting into voltage a reaction force generated when said object vibrates;

- a drive device driving said first piezoelectric element to induce said periodic vibration; and
- a device for detecting an output voltage from said second piezoelectric element.
- 2. A weight sensor device, comprising:
 - a table for receiving an object whose weight is to be measured;
 - a plurality of first piezoelectric elements connected with said table, said first piezoelectric elements inducing periodic vibration in said object;
 - a plurality of second piezoelectric elements fixed to said first piezoelectric elements in a coaxial fashion, said second piezoelectric elements converting into voltage a reaction force generated when said object vibrates;
 - a drive device driving said plurality of first piezoelectric elements; and
 - a device for detecting values of output voltages from said second piezoelectric elements.
- 3. A weight sensor device as in claim 1 or 2, further comprising an absorbing element between said first and second piezoelectric elements, said absorbing element absorbing a piezoelectric strain generated at a horizontal direction of said first piezoelectric element.
- 4. A weight sensor device as in claim 3, wherein said absorbing element comprises a plate.
- A weight sensor device as in claim 3, wherein said absorbing element has a pinpoint of intersection with each of said piezoelectric elements.
- A weight sensor device as in claim 3, wherein said absorbing element comprises a spherical component.
- A weight measuring apparatus comprising: a pair of piezoelectric elements;

an electrical stimulus connected to excite one element of said pair, thereby causing vibration of an object to be weighed, said vibration being communicated to the other element of said pair;

said other element producing a measurable electrical signal in response to said vibration, said measurable electrical signal being a measure of weight of said object.

- 8. The apparatus recited in claim 7, further comprising an absorbing element placed between said elements of said pair, said absorbing element absorbing piezoelectric strain generated in a direction different from a direction of force corresponding to the weight of said object.
- 9. A method of weighing an object, the method comprising the steps of:

placing said object in communication with a pair of piezoelectric elements;

applying an electrical stimulus to one of said piezoelectric elements thereby causing vibration of said object; and

measuring an electrical signal induced in the other piezoelectric element of said pair by a reactive force of said object generated in response to said vibration, said electrical signal representing a weight of said object.

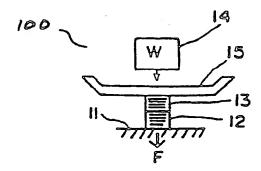
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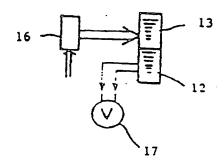
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FIGURE 1





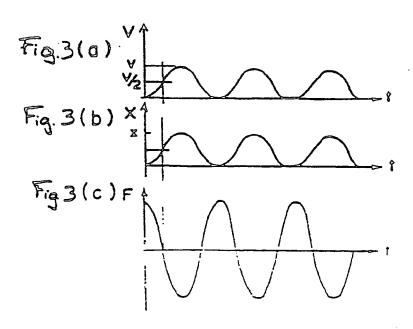


FIGURE 4

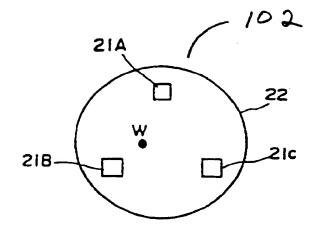


FIGURE 5

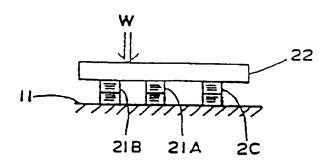
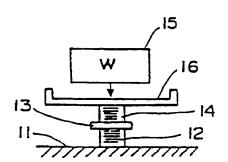


FIGURE 6



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FIGURE 7

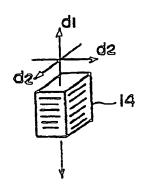
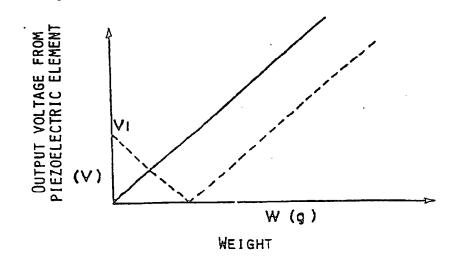
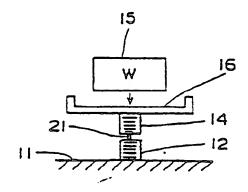
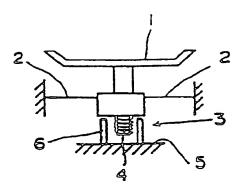


FIGURE 8





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EUROPEAN SEARCH REPORT

Application Number

EP 92 11 4736

	Citation of document with ind	ERED TO BE RELEVAN' ication, where appropriate,	Relevent	CLASSIFICATION OF THE	
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	* column 2, line 27	- line 38 *			
•	* column 3, line 35	- line 52; figure 2 *	2		
1	EP-A-0 270 693 (KRISTAL INSTRUMENTE AG) * abstract; figure 2 *		2		
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	* page 3, line 11 - * page 5, line 5 - 1	line 36 * ine 16; figure 1 *			
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